



Jessen 7-1-4

#101B
Bell
3-29-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of:

Group Art Unit: 2822

Scott Jessen, *et al.*

Examiner: Maria F. Guerrero

Serial No.: 09/966,157

Filed: 09/28/2001

Title: MASK LAYER AND INTERCONNECT
STRUCTURE FOR DUAL DAMASCENE
SEMICONDUCTOR MANUFACTURING

Commissioner for Patents
Box Fee Amendment
Washington, DC 20231

RESPONSE

Applicant submits this paper in response to the Office Action mailed
December 19, 2002, for which a response is due by March 19, 2002.

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